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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of: Eric NYRET et al.

Confirmation no. 1950

Application No.: 10/784,040

Group Art Unit: 2825

Filed: February 20, 2004

Examiner: L. H. Malsawma

For: **PREVENTIVE TREATMENT METHOD  
FOR A MULTILAYER SEMICONDUCTOR  
WAFER**

Attorney Docket No.: 4717-10100

*See Only*

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Office Action dated April 6, 2005 regarding the above-identified application.

**CLAIM AMENDMENTS** are reflected in the listing of claims which begins on page 2 of this paper.

**REMARKS** begin on page 5 of this paper.

No fees are believed to be due for this submission. Should any fees be required, however, please charge such fees to **Winston & Strawn LLP** Deposit Account No. 50-1814.